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OCT 21 2003

PATENT
Docket No. 150.00810102

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Brian A. Vaartstra) Group Art Unit: 2823
Serial No.: 09/865,612)
Confirmation No.: 4697)
Filed: May 25, 2001)
For: METHODS, COMPLEXES, AND SYSTEMS FOR FORMING METAL-
CONTAINING FILMS ON SEMICONDUCTOR STRUCTURES

FACSIMILE TRANSMISSION TO THE PTO

Assistant Commissioner for Patents
Attn: Mail Stop AF
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By: Loren D. Albin
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CERTIFICATE UNDER 37 C.F.R. §1.8: The undersigned hereby certifies that this Facsimile Cover Sheet and the
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Oct. 20, 2003

Date

Signature: Sara E. Olson
Name: SARA E. OLSON

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Dear Sir:

In response to the Office Action mailed August 20, 2003, please amend the above-identified application as follows:

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Amendments to the Claims are reflected in the listing of claims which begins on the page entitled "Amendments to the Claims."

Remarks begin on the page entitled "Remarks."